

JC Rec'd PCT/PTO 06 MAR 2002

219289US-0PCT

#9.6 (12)

1-14-03

GB

1-14-03

A.B.

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

YASUTAKA ITO ET AL :

ATTN: APPLICATION DIVISION

SERIAL NO: NEW U.S. PCT APPLN :

(Based on PCT/JP00/03041)

FILED: HEREWITH :

FOR: CARBON-CONTAINING ALUMINIUM:  
NITRIDE SINTERED BODY, AND  
CERAMIC SUBSTRATE FOR A  
SEMICONDUCTOR PRODUCING/  
EXAMINING DEVICE

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Prior to examination on the merits, please amend the above-identified application as follows.

IN THE TITLE

Please replace the title on page 1, lines 3-5 with the following title.

CARBON-CONTAINING ALUMINIUM NITRIDE SINTERED COMPACT

AND CERAMIC SUBSTRATE FOR USE IN EQUIPMENT

FOR MANUFACTURING OR INSPECTING SEMICONDUCTOR